

DOCKET NO: 295715US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
MASARU SASAKI, ET AL. : EXAMINER: MALEK, MALIHEH
SERIAL NO: 10/591,343 :
FILED: AUGUST 31, 2006 : GROUP ART UNIT: 2812
FOR: METHOD FOR MANUFACTURING :
SEMICONDUCTOR DEVICE AND
PLASMA OXIDATION METHOD

SUPPLEMENTAL REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action of October 22, 2008, and further to the Request for Reconsideration filed on April 22, 2009, Applicants request reconsideration in view of the following Remarks submitted concurrently with a Declaration under 37 C.F.R. § 1.131.

Remarks begin on page 2 of this paper.